

## **PATENT APPLICATION**

## N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76840

Tsutomu ASAKAWA, et al.

Appln. No.: 10/634,886

Group Art Unit: 1753

Confirmation No.: 7540

Examiner: Steven H. Versteeg

Filed: August 06, 2003

For:

METHOD OF PRODUCING AN ANTIREFLECTION-COATED SUBSTRATE

## AMENDMENT UNDER 37 C.F.R. § 1.114(c)

## MAIL STOP RCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 18, 2005, please amend the above-identified application as follows on the accompanying pages.